## IAPS Rec'd PCT/PTO 01 SEP 2006

10/591476

033082M343

## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuhiko KOJIMA, et al.

International Application No.: PCT/JP2005/003155

International Filing Date: February 25, 2005

U.S. Serial No.: To Be Assigned Group Art Unit: To Be Assigned

Filed: : Herewith Examiner: To Be Assigned

For: COPPER FILM DEPOSITION METHOD

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to or concurrent with calculation of the filing fees, please amend this application as follows.